



03560.002558.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yuji SUDOH et al.

Application No.: 09/532,022

Filed: March 21, 2000

For: EXPOSURE APPARATUS AND A

DEVICE MANUFACTURING METHOD

WHICH KEEP TEMPERATURE OF A

DIAPHRAGM OF A PROJECTION

OPTICAL SYSTEM SUBSTANTIALLY

CONSTANT

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: Examiner: H. Nguyen

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: Group Art Unit: 2851

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April 7, 2004

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In response the Notice of Non-Compliant Amendment mailed March 23, 2004, a corrected "IN THE CLAIMS" section is submitted.